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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

application of

: Mail Stop: ISSUE FEE

Masahiko SANO et al.

: Confirmation No. 8580

Serial No. 10/614,778

: [Group Art Unit 2814

Filed July 9, 2003

: Examiner Long Pham]

A METHOD FOR PRODUCING A NITRIDE
SEMICONDUCTOR ELEMENT

**AMENDMENT UNDER 37 CFR 1.312 AFTER RECEIPT
OF NOTICE OF ALLOWANCE**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
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Sir:

In response to the Notice of Allowance of July 1, 2004, please amend the above-
referenced U.S. patent application as follows:

Please
enter
UP (5/24/05)